TRANSFERRING TOOL

ABSTRACT OF THE DISCLOSURE

A transferring tool comprises: a first supporting bracket installed so as to be movable along a transferring tool guide of a semiconductor device handler; one pair of second supporting brackets coupled to the first supporting bracket with a gap therebetween, and having a plurality of pickers for picking-up semiconductor devices with a gap therebetween; and a vertical gap controller for controlling a gap of the pair of the second supporting brackets by moving the pair of second supporting brackets, wherein the vertical gap controller comprises: a vertical driving unit installed at the first supporting bracket for generating a vertical driving force; and a linear-motion unit installed at the first supporting bracket, and connected to the second supporting brackets, for controlling a gap between the second supporting brackets by being linearly-moved by the vertical driving unit.

Fig. 3